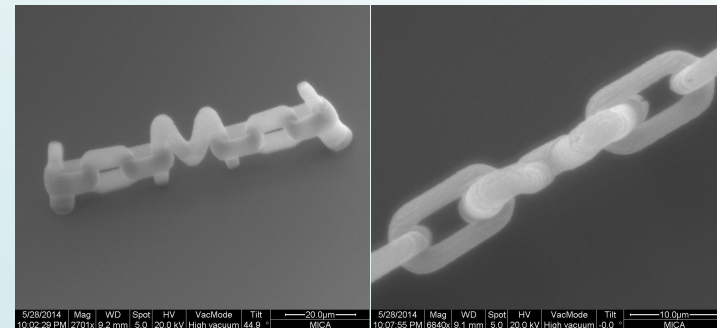


3D Microfabrication based on two-photon polymerization

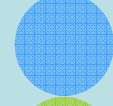
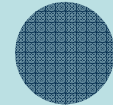
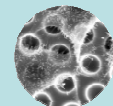
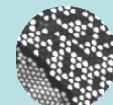
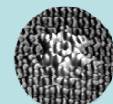
Arnaud Spangenberg

Institut de Science des Matériaux de Mulhouse (IS2M, CNRS-UHA) – France

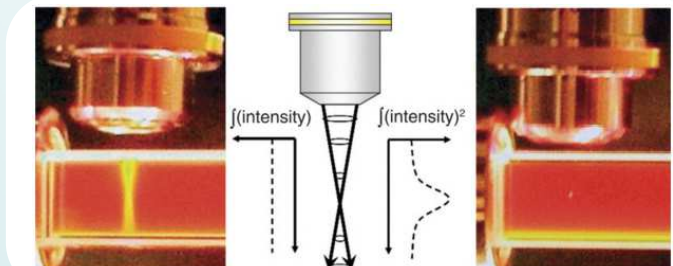
*Workshop on 3D Printing, Robotics and Medicine
Strasbourg – October 2018*



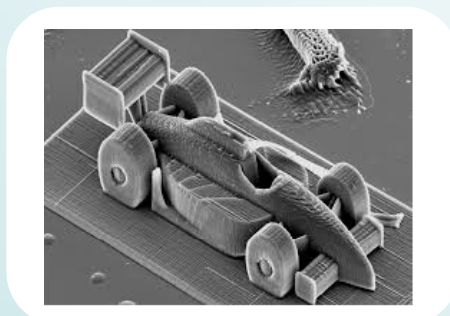
Outline



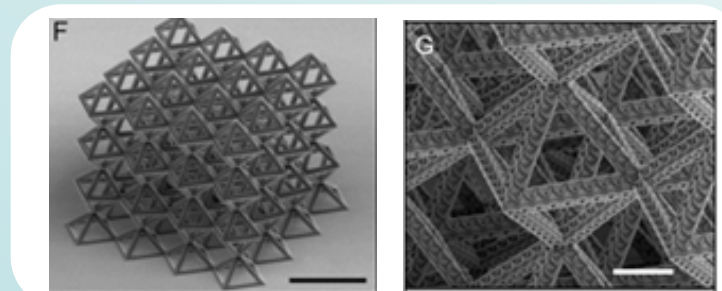
Outline



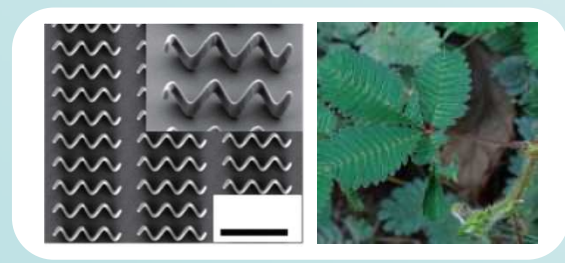
History & Principles of TPS



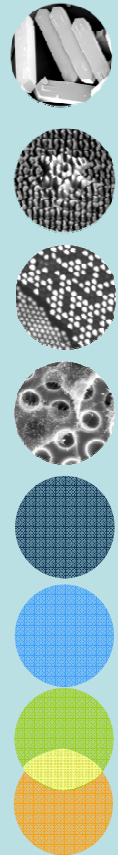
Writing speed & resolution



Applications
Medecine & Robotics



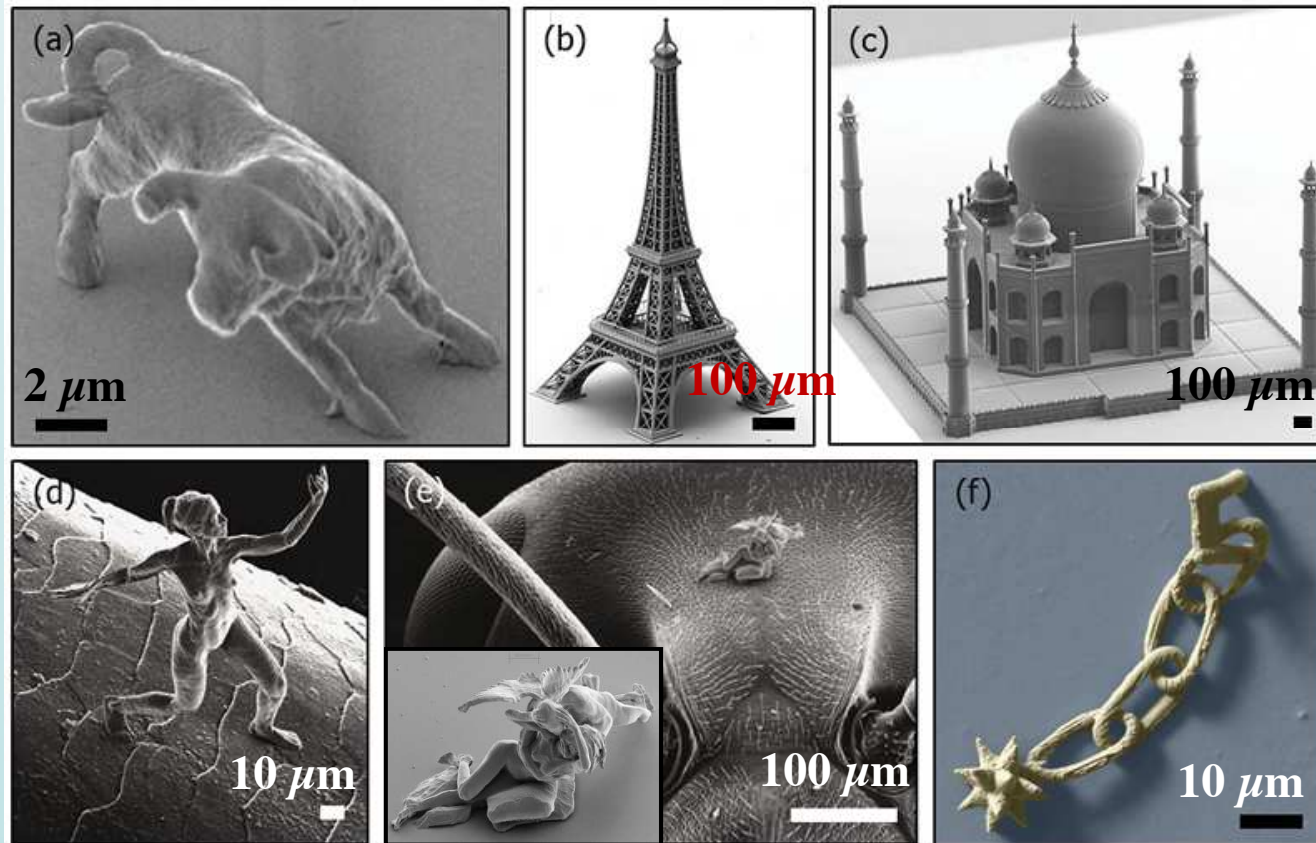
Advanced Functional
Materials



Two Photon Stereolithography (TPS)

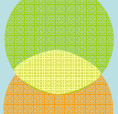
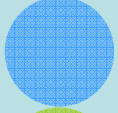
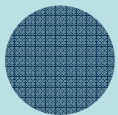
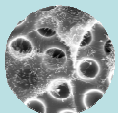
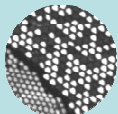
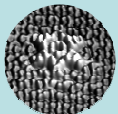
3 D Microstructuration by TPS:

- Nano-/microfabricated artwork by two-photon polymerization (TPP)



Yetisen et al. *Advanced Materials*, 2016, 28, 1724.

- a) Bull sculpture (*Kawata group*); b) Eiffel Tower, (*Nanoscribe GmbH*); c) Taj Mahal, (*Nanoscribe GmbH*)
d) Human sculpture. / Guinness World Record (80 x 100 x 20 micron), (*Jonty Hurwitz, artist*)
e) “Cupid and Psyche” on an ant head, (*Jonty Hurwitz, artist*); f) A morningstar with a chain (*Shear group*)



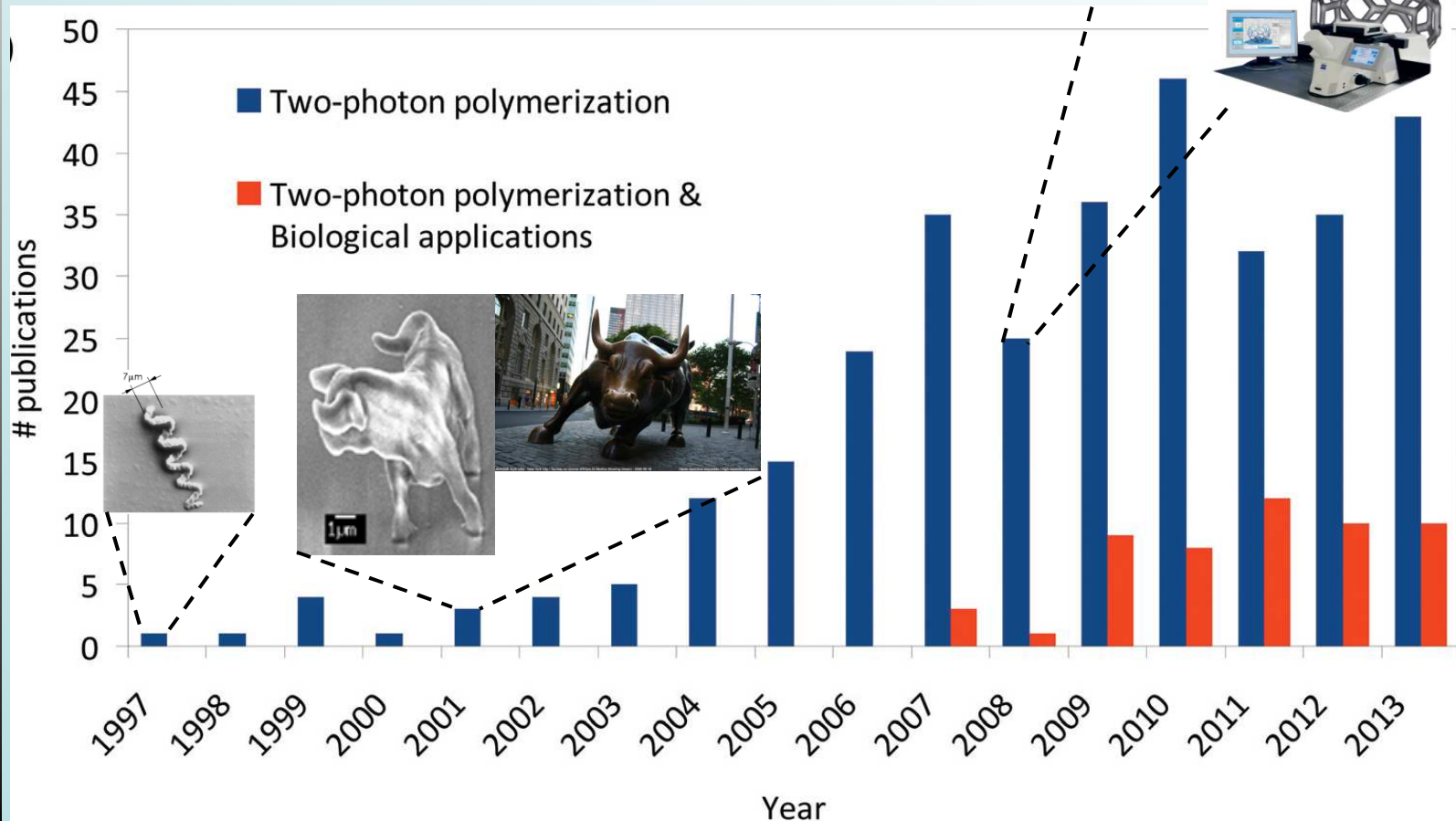
Significant milestones for TPS

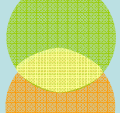
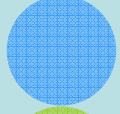
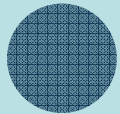
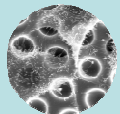
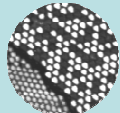
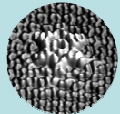
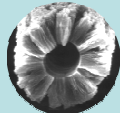
1992: two-photon lithography concept (*Strickler & Webb*)

1997: 1st experimental demonstration of TPS (*Maruo & Kawata*)

2001: Microbull (*Kawata*)

2008: commercial set-up for TPS ($\mu\text{m}\cdot\text{s}^{-1}$)





Significant milestones for TPS

1992: two-photon lithography concept (*Strickler & Webb*)

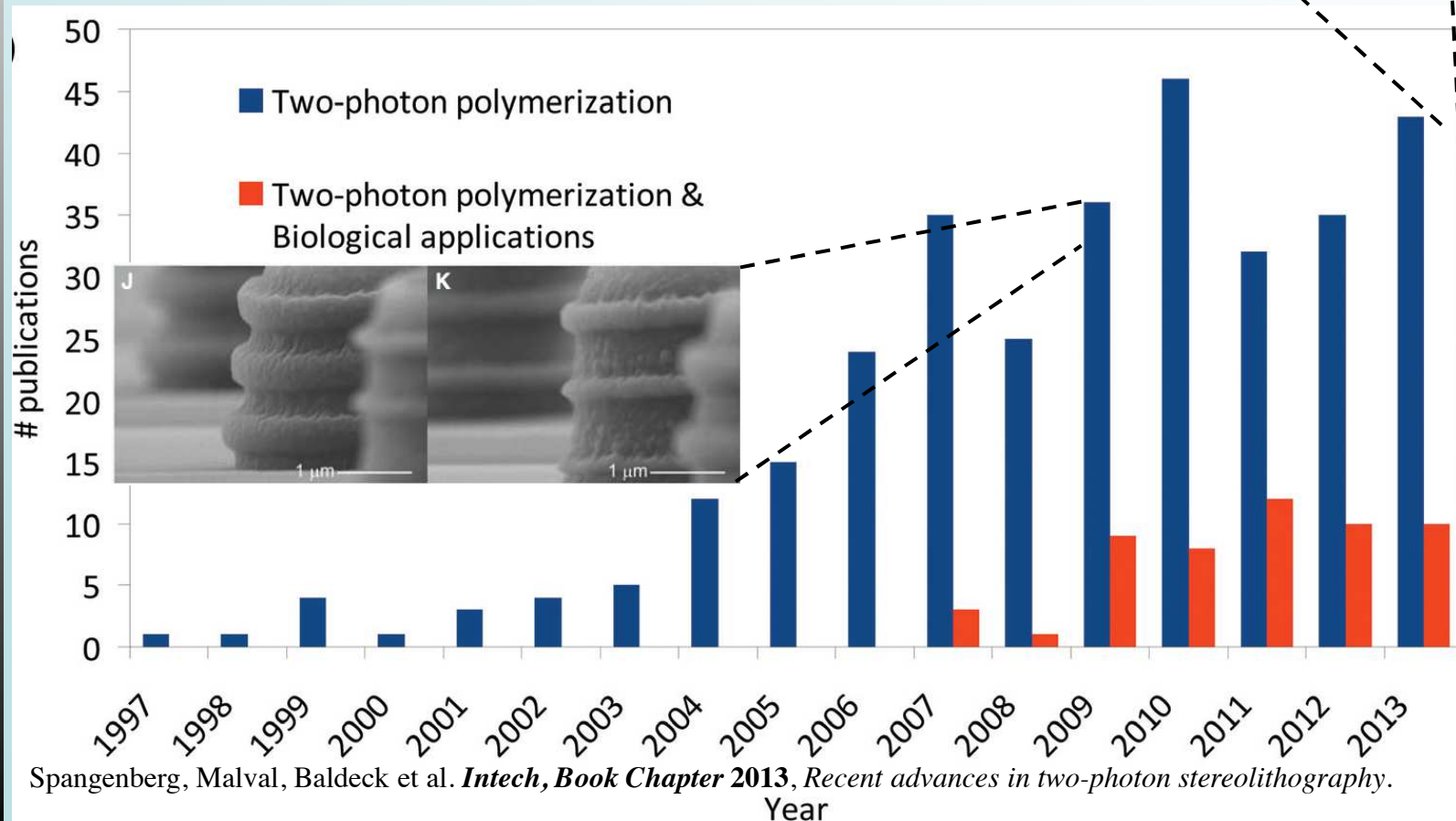
1997: 1st experimental demonstration of TPS (*Maruo & Kawata*)

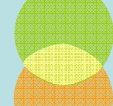
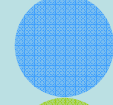
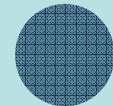
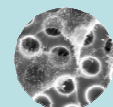
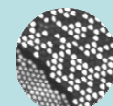
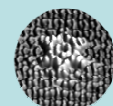
2001: Microbull (*Kawata*)

2008: commercial set-up for TPS ($\mu\text{m}\cdot\text{s}^{-1}$)

2009: STED-like TPS (*high resolution 3D microfabrication, Fourkas*)

2014: commercial set-up for fast TPS ($\text{m}\cdot\text{s}^{-1}$)



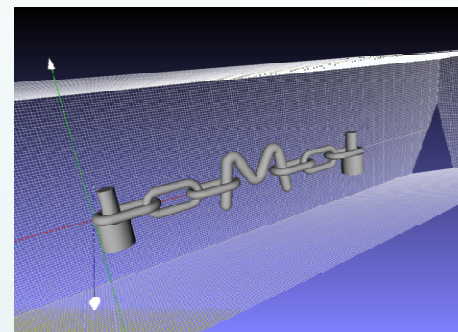


Key steps in two-photon stereolithography (TPS)

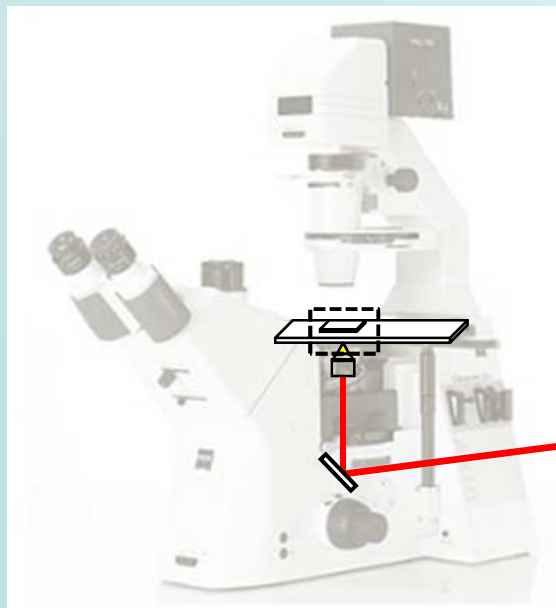
1. Identification of user needs
(shape, type of materials)



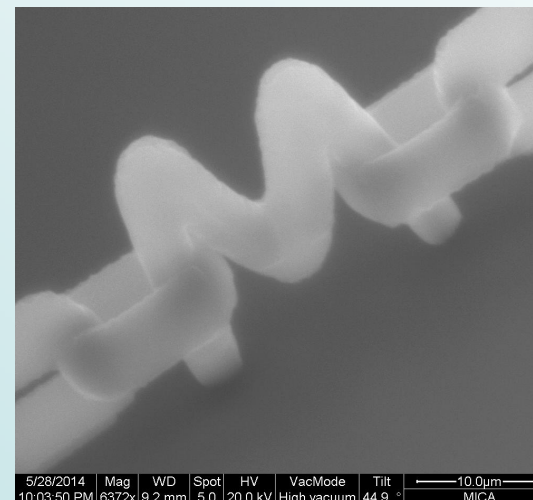
2. Computer aided design software
(CAD)

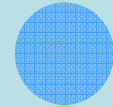
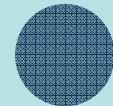
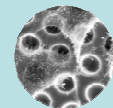
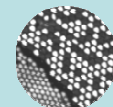
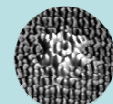


3. 3D Micro/Nanofabrication

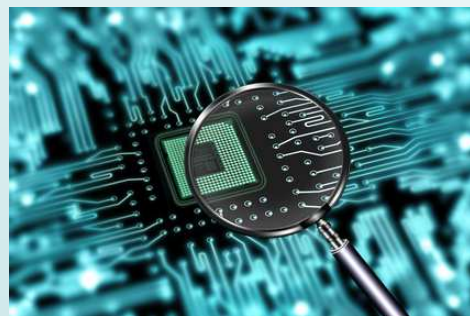


4. Characterization
(geometric, chemical, mechanical properties, ...)





Photopolymers in micro-nanofabrication



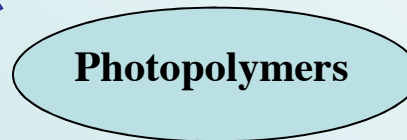
Micro/Nanotechnologies



Medicine (dentistry,...)



Optics



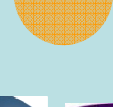
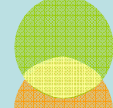
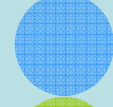
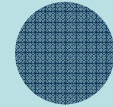
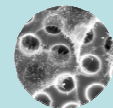
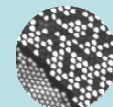
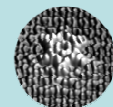
Adhesive (UV glues)



Cosmetics

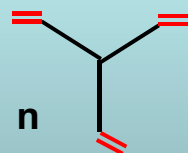


Coating (car, painting,...)



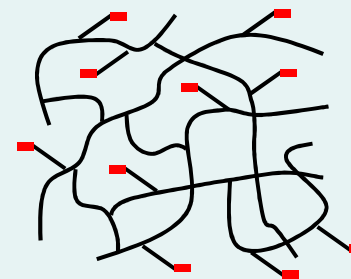
Photopolymers in micro-nanofabrication

Liquid Resin



light
→

Insoluble 3D polymer



Key components of Photopolymer:

- **Photoinitiators**
 - irradiation wavelength (from DUV to NIR)
 - excitation with 1 or 2 photons
 - efficiency (irradiation time and power)
- **Monomers**
 - final properties of materials (optical, mechanical)
 - conversion (% of reacted monomer)
- **Inhibitors**
 - confinement of the photoinduced reaction
- **Additives**
 - fluorescent, metallic, (...) NPs
 - dyes
 - other properties (conduction, magnetism,...)

Advantages :

- Broad range of materials / applications
- Ultra-fast polymerization (<1 sec)
- Reaction at room temperature, under air
- Low energy consumption
- Temporal and spatial control of the reaction

